

تمام احتمالی اعلان جو کس کو *

$\text{at } 300^\circ\text{K}$

کوئی کمیت نہیں *

TABLE 3.2 Summary of Important Equations for *p-n*-Junction Operation

Quantity	Relationship	Values of Constants and Parameters (for Intrinsic Si at $T = 300\text{ K}$)
Carrier concentration in intrinsic silicon (cm^{-3})	$n_i^2 = BT^3 e^{-E_G/kT}$ [1/ cm^3] نیکٹریٹ کی اگر رہا	$B = 5.4 \times 10^{31}/(\text{K}^3 \text{cm}^6)$ $E_G = 1.12\text{ eV}$ $k = 8.62 \times 10^{-5}\text{ eV/K}$ $n_i = 1.5 \times 10^{10}/\text{cm}^3$
Diffusion current density (A/cm^2)	$J_p = -qD_p \frac{dp}{dx}$ $J_n = qD_n \frac{dn}{dx}$	$q = 1.60 \times 10^{-19}\text{ coulomb}$ $D_p = 12\text{ cm}^2/\text{s}$ $D_n = 34\text{ cm}^2/\text{s}$
Drift current density (A/cm^2)	$J_{drift} = q(p\mu_p + n\mu_n)E$	$\mu_p = 480\text{ cm}^2/\text{V}\cdot\text{s}$ $\mu_n = 1350\text{ cm}^2/\text{V}\cdot\text{s}$
Resistivity ($\Omega\cdot\text{cm}$)	$\rho = 1/(q(p\mu_p + n\mu_n))$ [$\Omega\cdot\text{cm}$] $R = \rho \frac{A}{L}$ [Ω]	μ_p and μ_n decrease with the increase in doping concentration
Relationship between mobility and diffusivity	$\frac{D_n}{\mu_n} = \frac{D_p}{\mu_p} = V_T$	$V_T = kT/q$ $\approx 25.8\text{ mV}$
Carrier concentration in <i>n</i> -type silicon (cm^{-3})	$n_{n0} \approx N_D$ $p_{n0} = n_i^2/N_D$	

Quantity	Relationship	Values of Constants and Parameters (for Intrinsic Si at $T = 300\text{ K}$)
Carrier concentration in <i>p</i> -type silicon (cm^{-3})	Majority $p_{p0} \approx N_A$ Minority $n_{p0} = n_i^2/N_A$	(function of doping only!)
Junction built-in voltage (V)	$V_0 = V_T \ln\left(\frac{N_A N_D}{n_i^2}\right)$	(function of temperature)

Quantity	Relationship	Values of Constants and Parameters
Width of depletion region (cm)	$\frac{x_n}{x_p} = \frac{N_A}{N_D}$ $x_n = \frac{N_A}{N_D} x_p$ $W_{dep} = x_n + x_p$ $= \sqrt{\frac{2\epsilon_s}{q} \left(\frac{1}{N_A} + \frac{1}{N_D} \right)} (V_0 + V_R)$	$\epsilon_s = 11.7\epsilon_0$ $\epsilon_0 = 8.854 \times 10^{-14}\text{ F/cm}$

Quantity	Relationship
Charge stored in depletion layer (coulomb)	$q_J = q \frac{N_A N_D}{N_A + N_D} A W_{dep}$

Quantity	Relationship	Values of Constants and Parameters
Depletion capacitance (F)	$C_j = \frac{\epsilon_s A}{W_{dep}}$, $C_{j0} = \frac{\epsilon_s A}{W_{dep} _{V_R=0}}$ $C_j = C_{j0} / \left(1 + \frac{V_R}{V_0}\right)^m$ $C_j \approx 2C_{j0}$ (for forward bias)	$m = \frac{1}{3}$ to $\frac{1}{2}$

Quantity	Relationship
Forward current (A)	$I = I_p + I_n$ $I_p = A q n_i^2 \frac{D_p}{L_p N_D} (e^{V/V_T} - 1)$ $I_n = A q n_i^2 \frac{D_n}{L_n N_A} (e^{V/V_T} - 1)$
Saturation current (A)	$I_S = A q n_i^2 \left(\frac{D_p}{L_p N_D} + \frac{D_n}{L_n N_A} \right)$

Quantity	Relationship	Values of Constants and Parameters
Minority-carrier lifetime (s)	$\tau_p = L_p^2/D_p$, $\tau_n = L_n^2/D_n$	$L_p, L_n = 1\text{ }\mu\text{m to }100\text{ }\mu\text{m}$ $\tau_p, \tau_n = 1\text{ ns to }10^4\text{ ns}$

Quantity	Relationship
Minority-carrier charge storage (coulomb)	$Q_p = \tau_p I_p$, $Q_n = \tau_n I_n$ $Q = Q_p + Q_n = \tau_T I$

Quantity	Relationship
Diffusion capacitance (F)	$C_d = \left(\frac{\tau_T}{V_T}\right) I$

mass action law $\Rightarrow n \cdot p = n_i^2$ (for intrinsic)

" " " $\Rightarrow n_p \cdot P_{p0} = n_i^2$ (for doped)

for intrinsic

* $n_i = n = P = 0$

* at $T=0 \Rightarrow n = P = 0$

* There is only THERMAL generation & recombination

Doped \rightarrow Concentration of holes

$P_{p0} \rightarrow$ when doped with acceptor
at equilibrium.

$n_{p0} \rightarrow$ Concentration of electrons
when doped with acceptor
at steady state.

Ex 3.29 p. 106

Q. Calculate the intrinsic carrier density (n_i)

at : 250K, 300K, 200°C

$$\textcircled{1} \quad n_i^2 = B T^3 e^{-\frac{E_G}{kT}}$$

$$n_i^2 = 5.4 \times 10^{31} \times (250)^3 e^{\left(\frac{-1.12}{8.62 \times 10^{-5} \times 250}\right)}$$

$$n_i^2 = 2.26 \times 10^{16} \Rightarrow n_i = 1.5 \times 10^8 / \text{cm}^3$$

$$\textcircled{2} \quad n_i^2 = 5.4 \times 10^{31} (300)^3 e^{\left(\frac{-1.12}{8.62 \times 10^{-5} \times 300}\right)}$$

$$n_i^2 = 2.26 \times 10^{20} \Rightarrow n_i = 1.5 \times 10^{10} / \text{cm}^3$$

$$\textcircled{3} \quad T = 200 + 273 = 473 \text{ K}$$

$$n_i^2 = 5.4 \times 10^{31} \times (473)^3 e^{\left(\frac{-1.12}{8.62 \times 10^{-5} \times 473}\right)}$$

$$n_i^2 = 6.71 \times 10^{27} \Rightarrow n_i = 8.19 \times 10^{13} / \text{cm}^3$$

3.30 if we doped with donor $N_D = 10^{17}$, find electron and hole concentration at previous temperatures

$$\textcircled{1} \quad N_D = 10^{17} \Rightarrow \text{electrons} = 10^{17} / \text{cm}^3 = n$$

$$n.p = n_i^2 \Rightarrow \text{holes} = \frac{n_i^2}{n} = \frac{2.26 \times 10^{16}}{10^{17}} = 0.226 / \text{cm}^3$$

$$\textcircled{2} \quad n = N_D = 10^{17} / \text{cm}^3$$

$$P = \frac{n_i^2}{n} = \frac{2.26 \times 10^{20}}{10^{17}} = 2.26 \times 10^3 / \text{cm}^3$$

$$\textcircled{3} \quad n = N_D = 10^{17} / \text{cm}^3$$

$$\frac{n_i^2}{n} = P = \frac{6.71 \times 10^{27}}{10^{17}} = 6.71 \times 10^{10} / \text{cm}^3$$

Ex 3.31) find the resistivity of
 P3107 (a) intrinsic silicon (b) p-type with $N_A = 10^{16}/\text{cm}^3$

use $n_i = 1.5 \times 10^{10}/\text{cm}^3$, $N_n = 1350 \text{ cm}^2/\text{V}$, $\mu_p = 480 \text{ cm}^2/\text{V}$
 for intrinsic

use for doped $\mu_n = 1110 \text{ cm}^2/\text{V}$, $\mu_p = 400 \text{ cm}^2/\text{V}$

(*) find the resistance if $l = 3 \text{ nm}$, width = 3 nm , thick = $1 \mu\text{m}$

$$\textcircled{1} \quad \rho = \frac{1}{q(PN_p + nN_n)} \Rightarrow n = 1.5 \times 10^{10} = \rho \text{ for intrinsic}$$

$$\rho = \frac{1}{1.6 \times 10^{-19} \left[1.5 \times 10^{10} \times 1350 + 1.5 \times 10^{10} \times 480 \right]} \text{ cm} \text{ (الوحدة)}$$

$$R = \rho \frac{L}{A} = 2.28 \times 10^5 \times \frac{3 \text{ nm}}{3 \text{ nm} \times 1 \text{ nm}} = \frac{2.28 \times 10^5}{1 \times 10^{-4} \text{ cm}} = 2.28 \times 10^9 \Omega$$

$$\textcircled{2} \quad \rho = \frac{1}{q(PN_p + nN_n)} ; \quad P = N_A = 10^{16}/\text{cm}^3$$

$$n_i = 1.5 \times 10^{10} \Rightarrow n = \frac{n_i^2}{P} = \frac{(1.5 \times 10^{10})^2}{10^{16}}$$

$$= \frac{225}{10^6} = 22.5 \times 10^3/\text{cm}^3$$

$$\rho = \frac{1}{1.6 \times 10^{-19} (10^{16} \times 400 + 22.5 \times 1110)} = 1.56 \Omega \cdot \text{cm}$$

$$R = \rho \frac{L}{A} = 1.56 \times \frac{3 \text{ nm}}{3 \text{ nm} \times 1 \text{ nm}} = 1.56 \times \frac{1}{10^{-4} \text{ cm}} = 1.56 \times 10^4 \Omega$$

if doping is n-type $N_D = 10^{16} \text{ cm}^{-3}$

$$n = N_D = 10^{16} \Rightarrow \rho = \frac{(1.5 \times 10^{10})^2}{10^{16}} = 22.5 \times 10^3/\text{cm}^3$$

$$\rho = \frac{1}{q(nN_n + PN_p)} = \frac{1}{1.6 \times 10^{-19} (10^{16} \times 1110 + 22.5 \times 10^3 \times 400)} = 0.563 \Omega \cdot \text{cm}$$

Cont →

Cont / Some of problem 3.112

- * if temperature was increased to 473 K what is ρ for previous case ②. (n_i depends on T)

Ans: $N_A = 10^{16}/\text{cm}^3 = P$ يعتمد على الدرجة

$$n_i^2 = 6.71 \times 10^{27} \Rightarrow n = \frac{n_i^2}{P} = \frac{6.71 \times 10^{27}}{10^{16}} = 6.71 \times 10^{11} \text{ cm}^{-3}$$

يعتمد على الدرجة *

473 - see problem ①

$$\rho = \frac{1}{g(n_{Nn} \times P_{Np})} = \frac{1}{1.6 \times 10^{-14} (6.71 \times 10^{11} \times 1110 + 10^{16} \times 400)} = 1.56 \Omega \cdot \text{cm}$$

المسلسل المنهجي لحل المسائل

① ادرس تأثير درجة الحرارة بمحابي n_i ، n_i

② كسب P كثافة معرفة n_i, N_A

③ كسب n_i مع أحد المقطرين N_n, N_p لذراها في المجهزة

إذا كان المسؤول بالآخر من فقرة وينتشر في المقطرين

ابدأ في الخطوة ① حتى لا يتحقق بالحاجة .